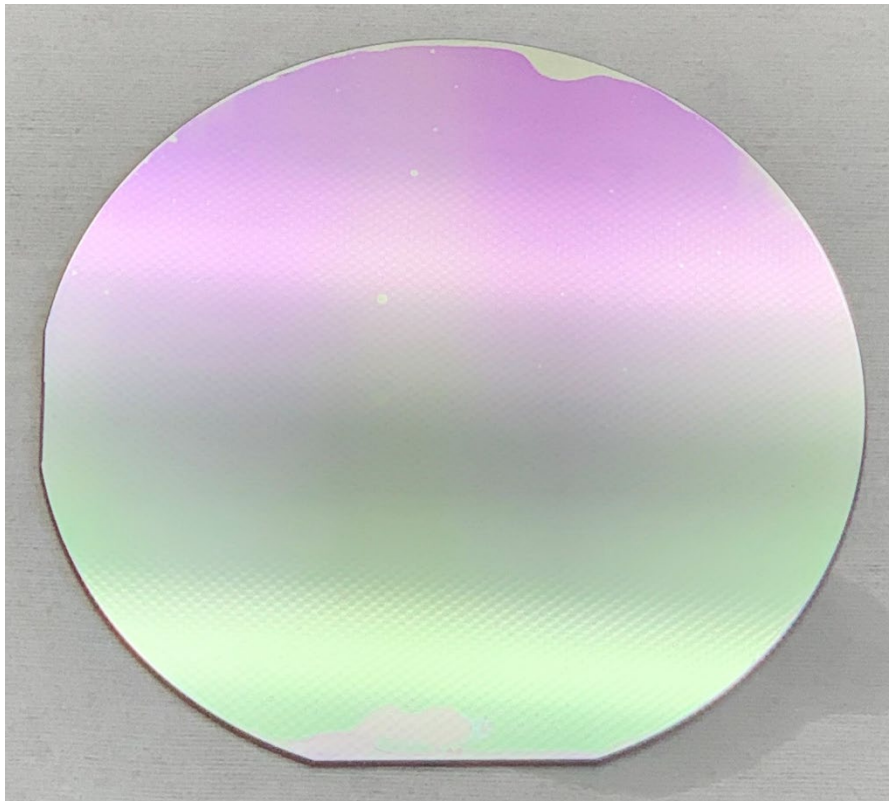


## **Wafer bonding service and ion Sliced lithium niobate thin films.**

Partow's technology is based on crystal ion slicing of lithium niobate wafers. The process uses ion implantation to weaken the crystal bondage in a lithium niobate wafer. The implanted crystal is then bonded to a handle substrate and a thin layer of lithium niobate is transferred to the handle substrates using crystal ion slicing technique. A final chemical-mechanical polishing step smoothens the surface of the bonded thin film wafer. Currently, the company produces customized photonic thin film platforms using its thin film bonding system and can extend its process to provide more customized bonded platforms based on customer's needs and application.



4" x-cut lithium niobate thin film on Silicon

**Lithium niobate single crystal thin film substrates**

Type	Low Thickness	High Thickness
<i>Top lithium niobate layer</i>		
<b>Parameter</b>	<b>Standard</b>	<b>Custom Order</b>
<b>Orientation</b>	Any orientation	Any orientation
<b>Doping</b>	Undoped, Black, MgO	Undoped, Black, MgO
<b>Secondary Flat (on LN film)</b>	TBD	TBD
<b>Lithium niobate film diameter</b>	100 mm	100mm
<b>Thickness range</b>	200-550nm	550-1000 nm
<b>Thickness uniformity</b>	< 2%	< 2%
<b>Surface roughness</b>	< 0.5 nm	< 0.5 nm
<b>Defective area &gt;50micron</b>	< 5%	< 5%
<b>Defect density &lt;50micron</b>	<1 per cm <sup>2</sup>	<1 per cm <sup>2</sup>
<i>Intermediate SiO<sub>2</sub> layer</i>		
<b>Type</b>	<b>Standard</b>	<b>Custom Order</b>
<b>Thickness range</b>	2000 nm	0 nm – 6000 nm
<b>Thickness uniformity</b>	< 3%	< 3%
<i>Substrate</i>		
<b>Type</b>	<b>Standard</b>	<b>Custom Order</b>
<b>Material</b>	Silicon, Quartz, Sapphire	Silicon, Quartz, Sapphire
<b>Substrate thickness</b>	0.5 mm	0.5 – 6 mm
<b>Substrate diameter</b>	100 mm	100 mm
<b>Substrate resistivity</b>	> 5000 ohm-cm	0-20000 ohm-cm

**Wafer bonding service:**

Parameter	Substrate 1	Substrate II
<b>Material</b>	Silicon, Lithium niobate, Quartz, GaAs, InP, diamond, Ga <sub>2</sub> O <sub>3</sub> .....	Silicon, Lithium niobate, Quartz, GaAs, InP, diamond, Ga <sub>2</sub> O <sub>3</sub> .....
<b>Diameter</b>	75 mm, 100mm	75 mm, 100mm
<b>Thickness</b>	0.5mm, or custom thickness	0.5mm, or custom thickness
<b>Surface roughness</b>	<0.5nm	<0.5nm